

Majority-Carrier Mobilities in Undoped and *n*-type Doped ZnO Epitaxial Layers

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Transparent and conductive ZnO:Ga thin films are prepared by laser molecular-beam epitaxy. Their electron properties were investigated by the temperature-dependent Hall-effect technique. The 300-K carrier concentration and mobility were about $n_s \sim 10^{16} \text{ cm}^{-3}$ and $440 \text{ cm}^2/\text{Vs}$, respectively. In the experimental ‘mobility vs concentration’ curve, unusual phenomenon was observed, i.e., mobilities at $n_s \sim 5 \times 10^{18} \text{ cm}^{-3}$ are significantly smaller than those at higher densities above $\sim 10^{20} \text{ cm}^{-3}$. Several types of scattering centers including ionized donors and oxygen traps are considered to account for the observed dependence of the Hall mobility on carrier concentration. The scattering mechanism is explained in terms of inter-grain potential barriers and charged impurities. A comparison between theoretical results and experimental data is made.

Keywords: ZnO, exciton, phonon, impurity.

I. INTRODUCTION

Semiconducting materials with a wide band gap, such as SnO_2 and In_2O_3 , are commonly used as transparent electrodes in optoelectronics and solar energy conversion technology. Recently, it has been demonstrated that ZnO:Ga may be considered as the next attractive transparent and conductive oxide compounds.

ZnO has a natural tendency to be grown under fairly high-residual *n*-type in which high concentration of charge carriers of about 10^{22} cm^{-3} may be achieved with group-III element doping. Therefore, highly conductive ZnO films are easily prepared.

To date, there have only been a few attempts [1, 2] to model electron transport in *doped* ZnO. The present publication reports carrier concentration dependence of mobility including an effect of the scattering by ionized donor centers as well as by the grain boundaries [3, 4].

II. EXPERIMENTALS

Our samples were grown on lattice-matched ScAlMgO_4 (SCAM) substrates by laser molecular-beam epitaxy. ZnO single-crystal and (Ga,Zn)O ceramics targets were ablated by excimer laser pulses with an oxygen flow of $1 \times 10^{-6} \text{ torr}$ [5, 6]. The films were patterned into Hall-bars and the contact metal electrodes were made with Au/Ti for *n*-type film, giving good ohmic contact.

III. RESULTS AND DISCUSSION

The ZnO materials parameters used in the transport theory calculation has been given elsewhere [7]. We have not adopted the relaxation time approximation for the mechanisms that involve relatively high-energy transfers, *e.g.*, longitudinal optical phonons. Since Rode’s iterative technique takes a long time to reach its convergence [3, 8], the present computations are based on the variational principle method [4, 9]. The following electron scattering mechanisms are considered: (1) polar optical-phonon scattering, (2) ionized-impurity scattering, (3) acoustic-phonon scattering through the deformation potentials, and (4) piezo-electric interactions [4, 9, 10].

The values of μ are $440 \text{ cm}^2/\text{Vs}$ and $5,000 \text{ cm}^2/\text{Vs}$ at 300 and 100 K, respectively. We have derived partial mobilities by accounting for respective scattering mechanisms in the nondegenerate (undoped) limit. The total electron mobility was calculated by combining all of the partial scattering mechanisms. Our experimental data are in reasonably good agreement with theory. The mobility limit at 300 K is about $430 \text{ cm}^2/\text{Vs}$.

On the other hand, the situation is somewhat different for the cases of Ga-doped *n*-type films [11]. Figure 1 shows 300-K experimental mobilities plotted against carrier concentration (n). The mobilities of doped films are significantly smaller than those of undoped one [12, 13]. Obviously, this tendency can be qualitatively attributed to the increased density of impurities. For quantitative comparison, partial mobilities are calculated and given in Fig. 1 by dashed lines. We have taken the effects of screening for both ionized impurities and polar optical phonon scattering into account. Polar interactions reflecting the ionicity of the lattice are dominant in scattering mechanism, while, at heavier doping levels, ionized impurity scattering controls inherent mobility limit curve [4, 9]. The experimental data agree well with our calculation (solid curve) except for the intermediate concentration range. Particularly, our model could not reproduce a relative minimum in the “ μ vs n_s ” curve, which has been experimentally observed in this intermediate doping range. The situation at $n_s > 10^{20} \text{ cm}^{-3}$ could be improved probably if the ef-

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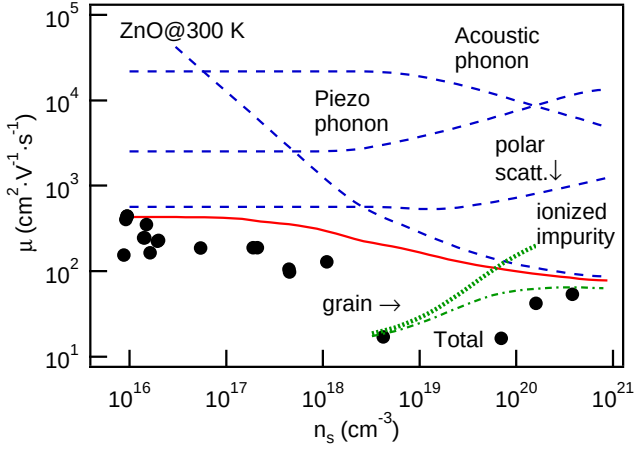


FIG. 1: Comparison of drift mobility calculations (solid red curve) with the Hall effect measurements for undoped and doped epitaxial films (filled black circles). The contributions of various scattering mechanisms to the total mobility are also shown by dashed blue curves. Also shown are the best fit (dash-dotted green curve) to the experimental data with contribution from scattering at grain boundaries (μ_b , dotted green curve).

fects of non-parabolic band structure as well as of clustering of charged carriers would be taken into account [1].

The presence of grain boundaries and trapped interface charges in semiconductors leads to inter-grain band bending and potential barriers [14]. Under specific conditions, this effect may be so prominent that it can significantly influence the scattering process of free carriers, giving rise to a considerable reduction in the Hall mobility.

It is well established that grain boundaries contain fairly high density of interface states which trap free carriers from the bulk of the grains. Such a grain may be thought of as a potential barrier for electrons characterized by its height E_b and width δ for a given number Q_t of traps per unit area.

The contribution μ_b (boundary partial mobility) to the total mobility μ_T that comes from the scattering at grain boundaries is thermally activated and can be described by the well-known relation:

$$\mu_b = \mu_0 \exp\left(-\frac{E_b}{kT}\right). \quad (1)$$

With $m\mu_0 = L_q(8\pi m^*kT)^{(-1/2)}$, where q is the charge of a trap (in this case $q = e$). By solving the Poisson equation, one obtains:

$$E_b = \frac{Q_t}{8\epsilon_0\epsilon_s N_d}, \quad (2)$$

where N_d is the concentration of ionized donors and other nomenclatures take conventional meanings.

Therefore in our model, we have two free parameters, i.e., Q_t and δ , that can be determined from the best fit of

$$\mu_T^{-1} = \mu_b^{-1} + \mu_{nb}^{-1}, \quad (3)$$

to the experimental data $\mu_H(n)$, where μ_{nb} (the full curve in Fig. 1) refers to all the partial mobilities except for μ_b .

We calculated the barrier height E_b according to Eq. (2). At low electron concentrations E_b is large, so we can infer that in that case the Hall mobility is barrier limited.

We compared our theoretical results with those experimentally determined. The best fit of our model including all of the contributions to the experimental dependence of μ_H on n for ZnO films is presented in Fig. 1. The best fit yields $7.5 \times 10^{13} \text{ cm}^{-2}$ and $\delta = 2 \text{ nm}$.

Partial contribution from μ_b is separated by a dash-dotted curve in Fig. 1 to give a better understanding of the scattering mechanism. The contribution from barrier-limited scattering is of no importance as far as high electron concentrations are concerned. Unfortunately, our model can be applied only to the case of degenerate semiconductor regime.

IV. SUMMARY

The electrical properties of wide band gap, degenerate ZnO thin films are investigated. The experimental dependences of the Hall mobility on the electron concentration is explained mainly in terms of scattering by grain boundaries and charged impurities. Oxygen accumulated in the grain boundaries plays an important role in the scattering mechanism.

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